

U.S. DEPARTMENT OF COMMERCE Patent and Trademark Office

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To the Honorable Commissioner for Patents and Trademarks: Please record the attached original documents or copy thereto:			
1. Name of Conveying Party(ies):	2. Name and address of receiving party(ies):		
Tsuyoshi OHNISHI	Name: HITACHI HIGH-TECHNOLOGIES		
	CORPORATION		
	Address: 24-14, Nishishinbashi 1-chome, Minato-ku		
Additional name(s) of conveying party(ies) attached? Yes No	Ĭ Ž Z		
3. Nature of Conveyance:	Tokyo , Japan ທຸເຄື		
	272 m		
☐ Security Agreement ☐ Change of Name	963		
Other	5-		
Execution Date: August 24, 2006			
	Additional name(s) & address(es) attached? Yes No		
4. Application number(s) or patent number(s):			
If the document is being filed together with a new application, the execution date of the application is: August 24, 2006			
A. Patent Application No(s).	B. Patent No(s).		
Additional numbers attached? Yes No			
5. Name and address of party to whom correspondence	6. Total number of applications and patents involved:		
concerning document should be mailed:	•		
Name: MCDERMOTT WILL & EMERY LLP	7. Total fee (37 CFR 3.41) \$40.00		
Internal Address:	Enclosed		
	Authorized to be charged to deposit account		
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9. Statement and signature.			
To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy			
of the original document.			
Keith E. George, 34,111	September 27, 2006		
Name and Registration No. of Person Signing	Signature Date		
To	stal number of pages including cover sheet: 2		
OMB No. 0651-0027 (exp. 6/30/2005)			

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ASSIGNMENT

(譲渡証)

As a below named inventor, I hereby declare that:

IN CONSIDERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me citizen of Japan by Hitachi High-Technologies Corporation, a corporation organized under the laws of Japan, located at 24-14, Nishishinbashi 1-chome, Minato-ku, Tokyo, Japan, receipt of which is hereby acknowledged I do hereby sell and assign to said Hitachi High-Technologies Corporation, its successors and assigns, all my right, title and interest, in and for the United States of America, in and to

CHARGED PARTICLE BEAM APPARATUS

invented by me (if only one is named below) or us (if plural inventors are named below) and described in the application for United States Letters Patent therefor, executed on even date herewith, and all United States Letters Patent which may be granted therefor, and all divisions, continuations and extensions thereof, the said interest being the entire ownership of the said Letters Patent when granted, to be held and enjoyed by said Hitachi High-Technologies Corporation, its successors, assigns or other legal representatives, to the full end of term for which said Letters Patent may be granted, as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made;

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said Hitachi High-Technologies Corporation.

Signed on the date(s) indicated aside signatures:

RECORDED: 09/27/2006

	INVENTOR(S) (発明者フルネームサイン)	Date Signed (署名日)
1) _	Tsayoshi Ohnishi Tsuyoshi OHNISHI	8/24/06
2)		
3) _		
4) _		
5) _		
6) _		
7) _		
8) _		
9) _		
10) _		

PATENT REEL: 018359 FRAME: 0941